Special Issue

Nanowires and Nanoprobes – Functionalized Arrays

Message from the Guest Editor

Nanowires not only represent one of the most important enabling technologies in electronics but have also lead to sensors with molecular scale sensitivity. This includes nanowire transistors and functionalized nanowire probes. We are calling for papers that highlight advances in nanowire research that may lead functional systems with an emphasis on detector arrays. As examples, we hope to gather articles that relate progress in the fabrication and utilization of arrays of nanowire transistor sensors and vertically oriented functional nanoprobes. The range of materials spans from Si and Ge to BN, metal oxides and carbon nanotubes. In recent research directed self-assembly has been utilized for device fabrication and functionalization. These platforms have exciting potential as electrical, chemical, optical, magnetic, and mechanical sensors that can provide highly sensitive spatial and temporal information about the systems being studied.

Guest Editor

Prof. Dr. Reginald C. Farrow

New Jersey Institute of Technology, University Heights Newark, Newark, NJ 07102, USA

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Micromachines
Editorial Office
MDPI, Grosspeteranlage 5
4052 Basel, Switzerland
Tel: +41 61 683 77 34
micromachines@mdpi.com

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Message from the Editor-in-Chief

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Editor-in-Chief

Prof. Dr. Ai-Qun Liu
1. Department of Electrical and Electronic Engineering, The Hong Kong Polytechnic University, Hong Kong, China
2. School of Electrical and Electronic Engineering, Nanyang Technological University, Singapore 639798, Singapore

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